## Notice of References Cited Application/Control No. 09/545,381 Applicant(s)/Patent Under Reexamination SPIELMANN ET AL. Examiner Beth Van Doren Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-			
	В	US-			
	C	US-			
	D	US-			
	Е	US-			
	F	US-			
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## **FOREIGN PATENT DOCUMENTS**

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<sup>\*</sup>A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.